

Serial No.

Group

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FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number (country code, no., kind code (if known))	Publication Date	Name of Patentee or Applicant	Pages, columns, lines where relevant passages appear	T
/B.K./	12.	JP 2004-034270	02/05/2004	II et al.		
↓	13.	JP 2003-073859	03/12/2003	Wada et al.		
↓	14.	JP 2003-045325	02/14/2003	Hatai et al.		
/B.K./	15.	EP 1319948 A2	06/18/2003	Dong		

OTHER DOCUMENTS

Examiner Initials	Cite No.	Include Author (in CAPITAL LETTERS), Title, Journal, Date, Pertinent Pages, Etc.	T
	16.	Commonly-assigned, co-pending U.S. Patent Application entitled, "Methods and Systems for Single- or Multi-Period Edge Definition Lithography," (Serial No. not yet assigned) (filed September 21, 2005).	
/B.K./	17.	International Search Report and Written Opinion in PCT Application No. PCT/US04/08724 (November 19, 2004).	
/B.K./	18.	International Preliminary Report on Patentability in PCT Application No. PCT/US04/08724 (May 31, 2005).	
/B.K./	19.	International Search Report in PCT Application No. PCT/US04/08725 (February 28, 2005)	

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